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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wagner
Serial No. : 10/826,823
Filed : April 15, 2004
Title : OPTICAL ARRANGEMENT AND PROJECTION EXPOSURE SYSTEM FOR
MICROLITHOGRAPHY WITH PASSIVE THERMAL COMPENSATION

Art Unit : 2851
Examiner : Fuller, Rodney Evan

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED MARCH 13, 2007

Please amend the application as indicated in the following pages:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

Signature

Typed or Printed Name of Person Signing Certificate